

FORM PTO-1449		US Dept. of Commerce Patent and Trademark Office		ATTORNEY DOCKET NO. ATMI-537-CIP		SERIAL NO. 10/632,009	
INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)				APPLICANT Chongying Xu, et al.		GROUP 2812 2818	
				FILING DATE July 31, 2003			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
PD	AA	5,840,897	11/24/1998	Kirlin, et al.			
	AB	5,453,494	9/26/1995	Kirlin, et al.			
	AC	6,110,529	8/29/2000	Gardiner, et al.			
	AD	5,820,664	3/31/1995	Gardiner, et al.			
	AE	5,225,561	9/12/1990	Kirlin, et al.			
	AF	5,789,027	8/4/1998	Watkins, et al.			
	AG	6,576,345 B1	6/10/2003	Van Cleemput, et al.			
	AH	5,211,342A	5/18/1993	Hoy, et al.			
	AI	6,207,522B1	3/27/2001	Hunt, et al.			
PD	AJ	10/632,009		Chongying Xu, et al.			11/25/2002
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES NO
							X (abstract only)
OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)							
PD	AK	Brian N. Hansen, et al., "Supercritical Fluid Transport-Chemical Deposition of Films" Chemical Materials, 1992, 4, 749-752.					
P17	AL	Jason M. Blackburn, et al., "Deposition of Conformal Copper and Nickel Films from Supercritical Carbon Dioxide" Science, Vol 294, October 5, 2001, pgs. 141-145					
PD	AM	C.Y. Xu, et al., "Supercritical Carbon Dioxide Assisted Aerosolization for Thin Film Deposition, Fine Powder Generation, and drug delivery", Green Chemistry, Editors: Anastas, Paul T., et al. Oxford University Press, Oxford, UK, pgs. 312-335.					
Continue on Page							
EXAMINER PHUOC T. DANG					DATE CONSIDERED 11/19/2004		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							